Paper No. 2004 126

PTO/SB/08A (10-96) (MODIFIED)
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Substitute to	Form 1449A/PTO	B E	BADDLATT	Complete if Known		
				Application Number	10/787,517	
	RMATION E			Filing Date	February 26, 2004	
STATEMENT BY APPLICANT				First Named Inventor	Bo Gu, et al.	
				Group Art Unit	1725	
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Sheet	1	of	3	Attorney Docket Number	GSIL 0191 PUSP	

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	Cite No.1	Offic	æ³	Nu	mber 4			Code*	Name of Patentee or Applicant of Cited Document	of Cited Document MM-DD-YYYY	Passages or Relevant Figures Appear	۳
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Substitute for	Form 1449B/PTO		Complete if Known				
INFOR	MATION	ISCLOSURE	Application Number	10/787,517			
		APPLICANT	Filing Date	February 26, 2004			
SIMIE	INIEIAI DI	APPLICANT	First Named Inventor	Bo Gu, et al.			
			Group Art Unit	1725			
	(use as many shee	ets as necessary)	Examiner Name				
Sheet	2	of 3	Attorney Docket Number	GSIL 0191 PUSP			
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

^{&#}x27;Unique citation designation number. Applicant is to place a check mark here if English language Translation is attached.

Paper No. 2004 1216

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		ISCLOSURE	Filing Date	February 26, 2004				
STATE	MENT BY	APPLICANT	First Named Inventor	Bo Gu, et al.				
			Group Art Unit	1725				
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Examiner	July 1	5.	Date Considered	June 27, 2005
Signature	Horney At	Coracy_	Considered	JUNG - 17 200)

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